## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

FUJISAKI et al

Serial No .:

Filed:

July 23, 2003

For:

III-V Single Crystal As Well As Method Of Producing The Same, And Semiconductor Device Utilizing The III-V Single Crystal

Art Unit:

Group:

## REAFFIRMATION OF CLAIM FOR PRIORITY

Mail Stop: Application Commissioner for Patents P.O. Box 1450

July 23, 2003

P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Under the provisions of 35 USC §119 and 37 CFR §1.55, Applicants hereby claim the right of priority based on Japanese Patent Application No. 208262/1984, filed in Japan on October 5, 1984.

The certified copy of the above-referred to Japanese Patent Application was filed on May 19, 1988 in prior application Serial No. 783,365, filed October 3, 1985.

Respectfully submitted,

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